SEP 2 0 2000 5

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re application of: PATRICK et al.

Attorney Docket No.: LAM1P061/P0318

Application No.: 08/925,985

Examiner: MARKOFF, A.

Filed: September 9, 1997

Group: 1746

Title: APPARATUS FOR IMPROVING ETCH

UNIFORMITY AND METHODS

THEREFOR

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Assistant Commissioner for Patents, Washington, D.C. 20231 on September 15, 2000

Signed:

Sua Funchass

AMENDMENT C

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

13/10

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SEP 22 2000

In response to the Office Action dated July 5, 2000, please amend the above-identified patent application as follows:

In the Claims:

All pending claims have been reproduced below for the convenience of the Examiner. Claims which have been changed by this amendment are indicated with an asterisk ("*").

*1. (Thrice Amended) In a plasma processing chamber, a method for improving etch uniformity while etching a semiconductor substrate, comprising:

placing said semiconductor substrate into a sacrificial substrate holder, said sacrificial substrate holder being configured to present a sacrificial etch portion surrounding said semiconductor substrate to a plasma within said plasma processing chamber to permit said plasma to etch a first surface of said semiconductor substrate and a first surface of said

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Title: APPARATUS FOR IMPROVING ETCH UNIFORMITY AND METHODS THEREFOR

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2000. Signed:

Sue Funchess

<u>AMENDMENT C TRANSMITTAL</u>

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

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	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	18	MINUS	18	0	x 9 =	x 18 =
Independent Claims	2	MINUS	2	0	x 39 =	' x 78 =
Multiple Dependent Claim Present and Fee Not Previously Paid			\$130.00	\$260.00		
				Total	\$	\$

	Applicant(s) hereby petition for a (s) extension of time to respond to the
_	aforementioned Office Action.
\boxtimes	Applicant(s) believe that no (additional) Extension of Time is required; however, if it is
	determined that such an extension is required, Applicant(s) hereby petition that such an extension
	be granted and authorize the Commissioner to charge the required fees for an Extension of Time
	under 37 CFR 1.136 to Deposit Account No. 50-0388 (Order No. LAM1P061).
	Enclosed is our Check No in the amount of \$ to cover the additional
	claim fee and/or extension of time fees.
\boxtimes	Please charge the required fees, or any additional fees required to facilitate filing the
	enclosed response, to Deposit Account No. 50-0388 (Order No. LAM1P061). A copy of this sheet
	is enclosed.

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

Michael Lee

Reg. No. 31,846

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